IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Teruo TAKIZAWA

Application No.: New U.S. Application

Filed: February 25, 2004

Docket No.: 118439

For:

SEMICONDUCTOR DEVICE AND METHOD OF MANUFACTURING THE SAME

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Pursuant to 37 CFR §1.56, the attention of the Patent and Trademark Office is hereby directed to the references listed on the attached PTO-1449. Unless otherwise indicated herein, one copy of each reference is attached. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the references be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

- \bowtie 1. This Information Disclosure Statement is being filed (a) within three months of the U.S. filing date of this non-CPA application, OR (b) before the mailing date of a first Office Action on the merits in the present application. No certification or fee is required.
- X English-language Abstracts of the non-English language references 1 and 2 are attached hereto.
- M A computer-generated English translation of the following Japanese Patent Publication has been obtained from the website of the Japanese Patent Office ([http://www.jpo.go.jp]), and is attached, but has not been reviewed for accuracy. See References 1 and 2.
- 冈 Relevance of the non-English language reference 1 is discussed in the present specification.

Registration No. 27,075

John S. Kern

Registration No. 42,719

JAO:JSK/mlo

Date: February 25, 2004

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DEPOSIT ACCOUNT USE AUTHORIZATION Please grant any extension necessary for entry; Charge any fee due to our Deposit Account No. 15-0461

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Form PTO-1449 (REV. 8-83)	US Dept. of Commerce PATENT & TRADEMARK OFFICE RMATION DISCLOSURE STATEMENT			ATTY DOCKET NO. 118439				APPLICATION NO. New U.S. Application			
(Use several sheets if necessary)				APPLICANT(S) Teruo TAKIZAWA				<u>.</u>			
				FILING DATE February 25, 2004			GROUP				
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	2.	JP A 10-12883 w/abstract & transl.	1/16/1998		JAPAN					-	
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Date: February 25, 2004